Study on Ion Temperature Behaviors in Electron and Ion Heating Regimes of ECH, ICRF and NBI Discharges in LHD


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Abstract

Ion heating experiments have been carried out in LHD using ECH (82.5, 84.0, 168GHz, ≤1MW), ICRF (38.5MHz, ≤2.7MW) and NBI (H° beam: 160keV, ≤9MW). The central ion temperature has been obtained from Doppler broadening of TiXXI (2.61Å) and ArXVII (3.95Å) x-ray lines measured with a newly installed crystal spectrometer. In ECH discharges on-axis heating was recently done with appearance of high $T_e(0)$ of 6-10keV and high ion temperature of 2.2keV was observed at $n_e=0.6 \times 10^{13}$ cm$^{-3}$. When the ECH pulse was added to the NBI discharge, a clear increment of $T_i$ ($\Delta T_i \sim 0.5$keV) was observed with enhancement of the energy flow from electron to ion. These results demonstrate the feasibility toward ECH ignition. In ICRF discharges $\Delta T_i \sim 0.8$keV was also observed at low density ranges of 0.4-0.6$\times 10^{13}$ cm$^{-3}$ with appearance of a new operational range of $T_i(0)=2.8$keV$>T_e(0)=1.9$keV. The obtained $T_i(0)$ data were plotted against $P_i/n_i$. The result strongly indicated that $T_i(0)$ smoothly increased with increasing $P_i/n_i$. The main reasons for the high $T_i$ achievement in the Ne discharges are; 1) 30% increment of deposition power, 2) increase in $P_i/n_i$ (5 times, $P_i/n_i >> P_e/n_e$, $P_i/P_e$) and 3) increase in $\tau_{ei}$ (3 times). The obtained $T_i(0)$ data were plotted against $P_i/n_i$. The main reasons for the high $T_i$ achievement in the Ne discharges are; 1) 30% increment of deposition power, 2) increase in $P_i/n_i$ (5 times, $P_i/n_i >> P_e/n_e$, $P_i/P_e$) and 3) increase in $\tau_{ei}$ (3 times). The obtained $T_i(0)$ data were plotted against $P_i/n_i$. The main reasons for the high $T_i$ achievement in the Ne discharges are; 1) 30% increment of deposition power, 2) increase in $P_i/n_i$ (5 times, $P_i/n_i >> P_e/n_e$, $P_i/P_e$) and 3) increase in $\tau_{ei}$ (3 times).
1. Introduction

Experiments in helical devices have been limited so far to only the electron heating regime \(P_e < P_i\) [1]. The ISS-95 sterallator scaling [2] was obtained from such ECH and NBI discharges. If the experiments in the ion heating regime \(P_i \geq P_e\) are realized, an increment of \(T_i\) and improvement of \(\tau_E\) are expected, since the ion confinement is generally better than the electron confinement. The heating experiments have been extensively carried out in LHD in order to obtain higher \(T_i\) and understand the heating mechanism. In this paper the results are reported, especially on the ion temperature behavior [3]. Ion temperature at the plasma center has been measured from Doppler broadening of ArXVII and TiXXI x-ray lines using a newly installed crystal spectrometer with a CCD [4]. The difference in ion temperature between the measured impurity ions \((\text{Ar}^{16+}, \text{Ti}^{20+})\) and bulk ions (ECH and NBI: \(\text{H}^+, \text{He}^{2+}\), ICRF: \(\text{He}^{2+}\), neon discharge: \(\text{Ne}^{10+}\)) is estimated to be smaller than 50eV at \(n_e=0.5 \times 10^{13} \text{ cm}^{-3}\).

2. \(\text{H}_2\) and He discharges

2.1 ECH: Results from off-axis ECH heating (82.7, 84 and 168GHz) are plotted in Fig.1(a). The \(T_e(0)\) is obtained from the YAG Thomson scattering measurement. The \(T_i(0)\) is much lower than \(T_e(0)\) in the low-density range and becomes equal at \(n_e\sim 1 \times 10^{13} \text{ cm}^{-3}\). The electron-ion heat exchange time, \(\tau_{ei}\), becomes equal to the energy confinement time, \(\tau_E\), \((\sim 150 \text{ ms})\) at \(n_e\sim 1.1 \times 10^{13} \text{ cm}^{-3}\). The power flow from electrons to ions at the plasma center ranges in 3-6kWm\(^{-3}\) at \(n_e>0.5 \times 10^{13} \text{ cm}^{-3}\) and 0.4-2kWm\(^{-3}\) at \(n_e<0.5 \times 10^{13} \text{ cm}^{-3}\). If the ion confinement time of \((3-5)*\tau_i\) is taken into account, the \(T_i(0)\) can be roughly explained by the

![Fig.1 Comparison between \(T_i(0)\) and \(T_e(0)\) as a function of line-averaged density \(n_e\) in (a) ECH (0.4-0.6MW), (b) \(\text{H}_2\) NBI (<8MW), (c) ICRF (1MW), (d) He NBI+ICRF (<4MW+1MW) and (e) high-power NBI discharges (≤8MW). Open squares in (e) indicate \(T_i(0)\) from Ne discharges.](image-url)
power input from electrons. Recently, on-axis ECH heating was carried out, and high $T_i(0)$ of 2.2keV has been observed with the appearance of high $T_e(0)$ such as 6-10keV [5,6]. The power flow from electrons to ions increased 2-3 times (see also Fig.1(a)). Furthermore, the ECH pulse was added to the NBI discharge. A clear increment of $T_i(0)$ was also observed as shown in Fig.2. These results strongly suggest the feasibility toward ECH ignition in future high-power and high-density ECH discharges. The global increase of $T_e$ was important for the $T_i$ increment, not related to the sharp peak near plasma center.

2.2 NBI; NBI heating in LHD is carried out at high beam energy of 160keV [7,8]. The beam shine-through power becomes considerably high (50% at 1x10^{13}cm^{-3}) and an input power greater than 70% is absorbed by electrons ($P_i<P_e$, $P_i/n_i<P_e/n_e$). The ion heating in NBI discharges is entirely inefficient. As a result (see Fig.1(b)) the electron temperature becomes higher than the ion temperature in the low density region. Here, the fraction deposited to bulk ions ($P_i/P_{NBI}$) was 28% at $T_e=3$keV and 19% at $T_e=2$keV. The total $P_i$ becomes 1.2MW at $n_e=1x10^{13}$cm^{-3} and 0.8MW at $n_e=0.5x10^{13}$cm^{-3} in the case of $P_{NBI}=8$MW, if the charge exchange loss can be neglected.

2.3 ICRF; Successful results [9-11] from ICRF (38.5MHz, H: minority, He: majority, $P_{ICRF}=1$MW) discharges are shown in Fig.1(c). An increment of $T_i(0)$ was clearly observed in a range of $0.4\leq n_e \leq 0.6x10^{13}$cm^{-3}. The bulk ions are heated through high-energy H$^+$ ions accelerated up to 200keV ($T_{tail}(H^+)$=25keV). The deposition profiles are calculated with a 5-D code by Murakami [12]. The results showed a broad ion deposition profile with a certain central deposition of 7kWm^{-3} at $\rho=0$ and 18kWm^{-3} at $\rho=0.5$, whereas the bulk electron heat deposition profile was located in a range of $0.4\leq \rho \leq 0.8$. The fraction of bulk ion heating, $P_i/P_{ICRF}$, was roughly 60%. Thus, a new operational range of $T_i>T_e$ was established with a successfully performed ion heating regime ($P_i>P_e$, $P_i/n_i>P_e/n_e$).

2.4 ICRF+NBI; The ICRF pulse was added to the NBI discharge ($\leq 4$MW). The result is shown in Fig.1(d). Since the ICRF heating, at present, is not effective at $n_e>2x10^{13}$cm^{-3}, the

![Fig.2 Ion heating during additional ECH pulse in H2 NBI discharge (left) and electron temperature profiles before (1.965s) and during (2.485s) the ECH pulse (right).](image-url)
data are plotted in lower density range. We understand that the ion temperature can be also raised up by the combination with NBI because of the further increase in $P_i$.

The obtained $T_i$ was compared with ISS-95 scaling under the assumption of $T_i=T_e$ (Fig.3). The value expected from the scaling is traced with the lower solid line of $1.44*P_{tot}^{0.41}/n_e^{0.49}$. In NBI discharges the $T_i(0)$ is a weak function of $P_{tot}/n_e$. On the contrary, most of the data from the ICRF and NBI+ICRF discharges exceed the scaling value, and those suggest an improvement of the heating efficiency of 60% at the maximum indicated by the upper solid line of $2.3*P_{tot}^{0.41}/n_e^{0.49}$. This increment of $T_i(0)$ originates in the presence of ICRF pulse.

3. Neon discharge

Neon discharges [13,14] were tried using NBI to obtain a higher $T_i$. A nearly pure Ne discharge ($Z_{eff}$∼8.5) was successfully obtained because the main part of the neon radiation could be excluded from the core plasma and emitted in the ergodic layer outside $\rho=1$, which characterizes LHD. The highest ion temperature of 5keV was obtained with achievement of $T_i>T_e$ in the Ne discharges (Fig.1(d)). The global energy confinement was the same as the $H_2$ and He discharges. The main reasons why the high-$T_i$ range was extended are; 1) increase in the NBI deposition at lower density ranges (+30%) (Fig.4(a)), 2) increase in the bulk ion heating fraction following the $T_e$ increase (Fig.4(b)), 3) increase in $P/n_i$ (5 times, $P/n_i>>P/e$, $P>\%P_e$) and 4) increase in $\tau_{ei}$ (3 times) (Fig.4(c)). Here, the $q_i(0)$ becomes $\sim200kWm^{-3}$ at $n_e=0.6x10^{13}cm^{-3}$ for $P_{NBI}=8MW$. The Ne ion density is mainly calculated from density rise after Ne gas puffing. Contribution of $H^+$ and He$^{2+}$ ions to the $n_i$ is

![Fig.3 $T_i(0)$ plot by ISS-95 scaling.](image1.png)

![Fig.4 (a) NBI deposition rate of $H_2$, He and Ne, (b) ratio of bulk ion heating to total NBI input power and (c) $\tau_{ei}$ for $H_2$ discharge and $\tau_{ei}$ for $H_2$ and Ne discharges.](image2.png)
estimated from $Z_{eff}$ values and visible and VUV spectroscopy, especially using recombination emissions at the end of discharges.

The obtained ion temperatures are plotted against $P_{tot}/n_e$ (Fig. 5(a)). The difference between the Ne and $H_2$ discharges is notable. The same data set as in Fig. 5(a) was also replotted as a function of $P_i/n_i$ (Fig. 5(b)). It is seen that the $T_i(0)$ smoothly increases with increasing $P_i/n_i$. However, it should be noticed that the values of $n_i$ is sensitive to the presence of $H^+$ and $He^{2+}$ ions in the Ne discharges. Direct measurement of the ion density is necessary to increase the accuracy. Nevertheless, the two figures strongly suggest the importance of the direct power input to bulk ions in order to realize higher ion temperature.

In conclusions, a new parameter range of $T_i>T_e$ was found in LHD for ICRF and Ne-seeded NBI plasmas with achievement of the highest ion temperature of 5keV. The $T_i$ increase in on-axis ECH heating also revealed feasibility toward ECH ignition.

References